

**INVESTIGATION OF THE HIGH-Z
LASER-PRODUCED PLASMA WITH THE USE OF ION DIAGNOSTICS
FOR OPTIMIZATION OF THE LASER INTERACTION
WITH THE HOHLRAUM-TYPE TARGETS**

The 3rd Progress Report on the IAEA Research Project No. 11535

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OUTLINE

- 1. Introduction.**
- 2. Comparison of ion emission from high-Z plasmas generated by the high energy PALS laser at the fundamental and the 3rd harmonic frequencies.**
- 3. Correlation of the x-ray and ion emissions from high-Z plasmas generated by the high energy PALS laser.**
- 4. Fast ion generation in the plasma produced by a 1-ps high intensity laser pulse.**
- 5. Summary.**

Research Coordination Meeting

4-7 November 2003, IAEA Headquarters, Vienna, Austria

1. INTRODUCTION

- Studies of *high-Z plasma produced with high-power laser* are directed towards the determination of *physical processes* in such a plasma (e.g., energy transformation and transport, X-ray generation, ionization and recombination, ion acceleration, nonthermal phenomena and others) as well as towards *important applications: optimisation of indirect laser fusion*, X-ray laser-plasma source and sources of multi-charged ions.
- The *main objective of this project is application of ion diagnostic methods* to investigate the physical properties of *high-Z plasma generated by laser* beams similar to the plasma produced inside the Hohlraum.
- In this project we would like to determine the *characteristics of this plasma* in dependence on *laser pulse parameters* (intensity, pulse duration, wavelengths, energy), illumination geometry (focus position, target tilt angle) and *target material*.
- Combined measurements of high-Z laser-produced plasma using *different diagnostic methods* are better for quantitative *analysis of the processes* essential for optimal indirect implosion of thermonuclear capsule.

1. INTRODUCTION (continued)

- The experiments described here *were continuation of the previous investigations* of specific features of *high-Z plasma* generated by the high-power performed within this project.
- These studies were carried out at the *IPPLM in Warsaw* with use of the IPPLM CPA Nd:glass laser generating 1-ps or 0.5-ns pulses at $\lambda = 1.05 \mu\text{m}$ and at the *PALS Research Centre in Prague* with the use of the iodine PALS laser system with output energy up to 750 J at the fundamental wavelengths (1.315 μm) or up to 250 J at the 3rd harmonic (0.438 μm) in a 0.4 ns pulse.
- Investigations are carried out by means of *diagnostic devices used in the preliminary experiment* (i.e. ion collectors, a cylindrical electrostatic ion energy analyzer and X-ray detectors) and additionally with the use of *modernised ion collectors, improved X-ray detectors and nuclear track detectors for fast ions*.
- The investigations performed at the PALS Research Centre in Prague were carried out within *multilateral co-operation* with the Institute of Physics and Institute of Plasma Physics ASCR in Prague and with scientists from several other institutes.

2. Comparison of ion emission

***from high-Z plasmas generated by a high energy PALS laser
at the fundamental and at the 3rd harmonic frequencies***

**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

INTRODUCTION

The ion emission from laser-produced plasmas is a well known phenomenon which has been studied since the early 1960s.

For a long time the interest in studies of the ion emission has been stimulated by the importance of this phenomenon for *laser-driven inertial confinement fusion*.

In more recent works, however, some *useful aspects* of ion emission from laser-produced plasma have been emphasised.

In particular, the possibility of applying laser-driven ion sources (LIS) in *accelerator technology and for modifying material properties* through ion implantation has been suggested and investigated.

The energy of an intense laser pulse interacting with a target *is not completely transferred to the plasma in the collisional (thermal) processes*.

In particular, as a result of the *long-wavelength laser-plasma interaction*, the nonthermal coupling processes transfer a part of laser energy into the energy of *hot electrons*.

The *fast ions* appear as a result of ion acceleration in the *electrostatic field created by the electrons*.

**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

INTRODUCTION (continued)

The efficiency of the *hot electron production decreases* with the *decreasing of the laser wavelength*.

There are also several *nonlinear phenomena* (e.g. filamentation and self-focusing of the high intensity laser beam, ponderomotive forces) *weakly dependent on the laser wavelength*, which can lead to the fast ion production in the case of the *short-wavelength laser-plasma interaction*.

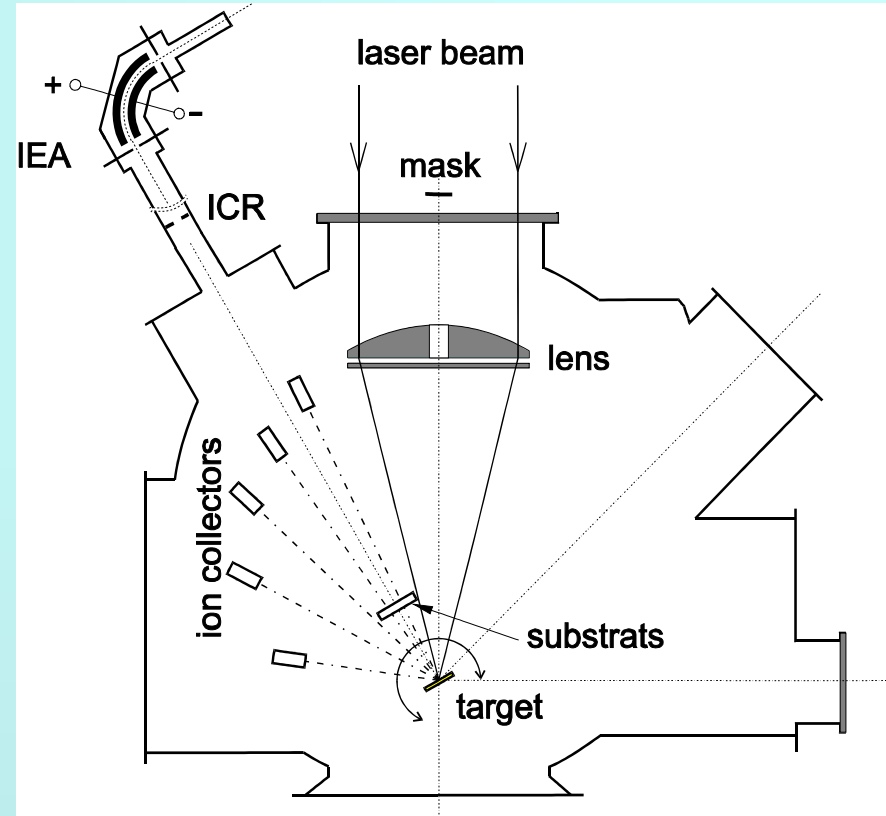
It is interesting *to compare the characteristics of fast ions accelerated* in plasmas produced by the intense long- and short-wavelength laser radiation in similar experimental conditions.

**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

EXPERIMENTAL ARRANGEMENT

The PALS laser parameters:

- energy of **0.4-ns** pulse at wavelength of **1315 nm ($1\omega_0$): $< 750\text{ J}$** at wavelength of **438 nm ($3\omega_0$): $< 250\text{ J}$**
 - power density – up to **10^{16} W/cm^2** (at spot diameter of **$\sim 70\text{ }\mu\text{m}$**).
- * The laser beam was focused onto a slab targets (Cu, Ag and Ta) by means of an aspherical lens at an **angle of 30°** with respect to the target normal.
- * Five ion collectors **were located inside the vacuum chamber, at angles from 4° to 52° with respect to the target normal and at distances of 30–60 cm from the target surface.**
- * The ion energy analyzer (IEA) and a "ring" ion collector (ICR) were placed far from the target perpendicularly to the target surface.
- * Additionally, the **solid-state nuclear track detectors** (PM-355) uncovered as well as **masked with 0.75, 1.5 and $4\text{ }\mu\text{m}$ Al-foils** were also used for measurements of **high-energy ions**.



IEA – ion energy analyzer, ICR – “ring” ion collector

**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
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ELECTROSTATIC ION ENERGY ANALYZER (IEA)

The IEA gives a possibility to *distinguish all ionization states and energy of ions* at a long distance from the target. Only ions with particular values of m/z can pass through the IEA and reach the detector (WEM).

From the equation of motion:

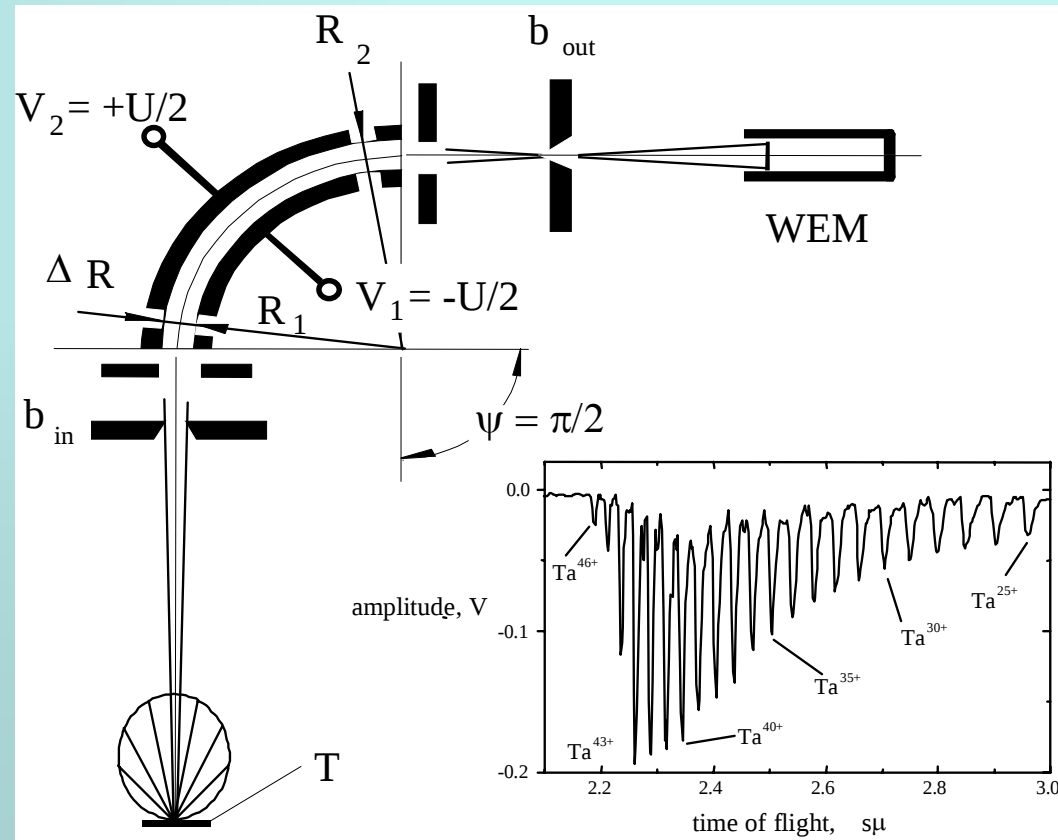
$$E/z = \kappa eU$$

and time-of-flight of ions on the path L_{IEA}
from the target to the detector:

$$t = L_{IEA}(m_i/2E_i)^{1/2} = L_{IEA}[m_i/(2ez\kappa U)]^{1/2}$$

where: E_i – kinetic energy,
 m_i – ion mass,
 z – charge state,
 κ – geometric factor,
 e – elementary charge,
 U – deflection voltage

one can determine the *essential parameters of
particular ion species*.

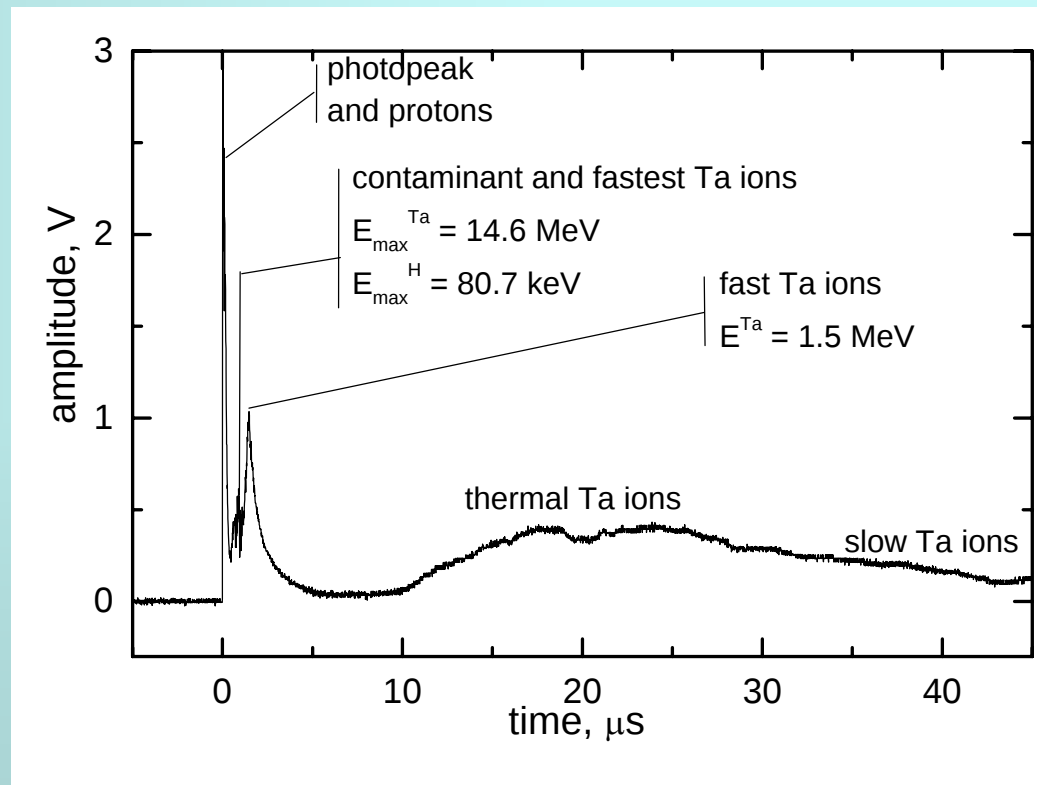


2. Comparison of ion emission from high-Z plasmas generated by a high energy PALS laser at the fundamental and at the 3rd harmonic frequencies

AN EXAMPLE OF ION COLLECTOR SIGNAL OF Ta PLASMA

Ion collector signal shows the occurrence of *different group of ions* reaching the IC.

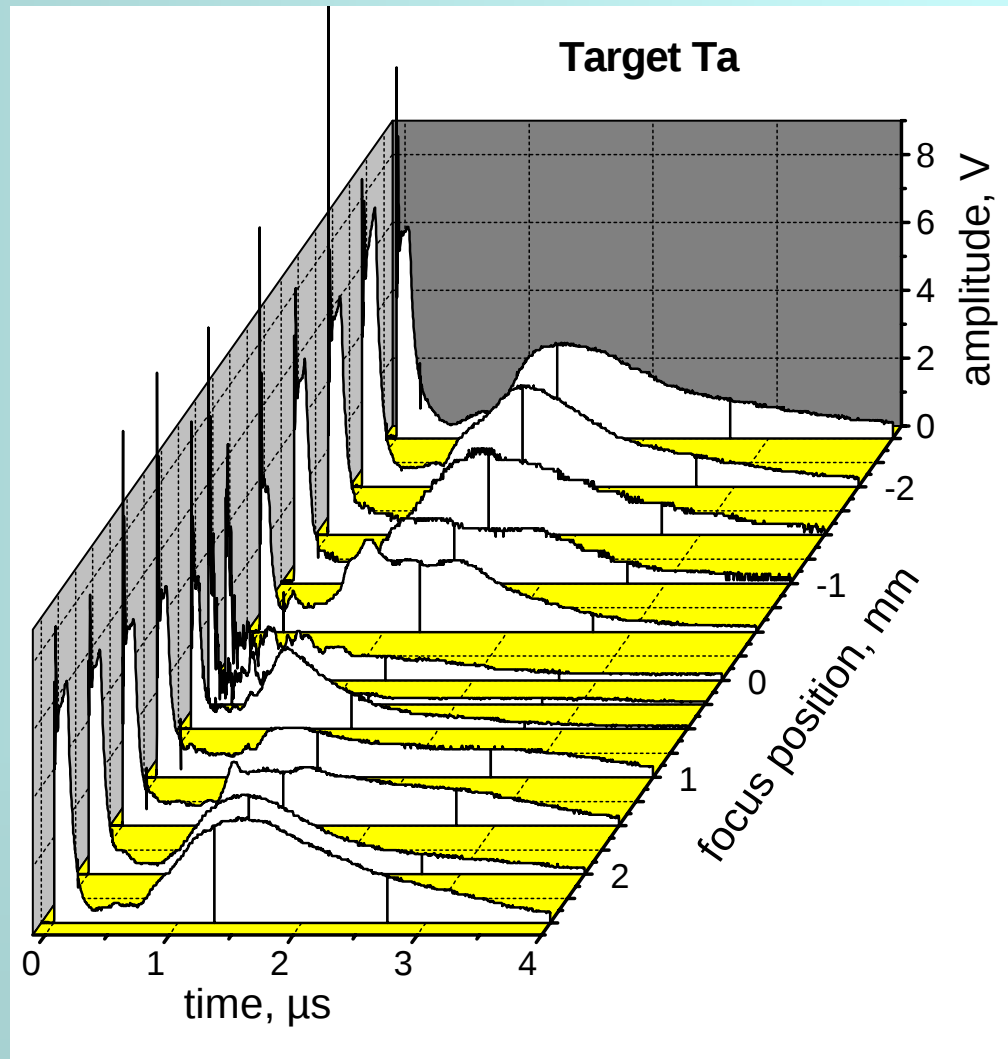
- ▶ The first maximum represents photopeak and *contaminant ions* (mainly protons).
- ▶ The second ion group consists of *fast, high-Z ions*.
- ▶ The third one corresponds to *thermal high-Z ions*.
- ▶ The forth one consists of *slow high-Z ions* generated indirectly around the laser focus spot by the X-rays emitted from the hot plasma.



The IC signal was recorded at the distance of 182.2 cm from the target along the target normal ($3\omega_0$, laser energy = 200 J)

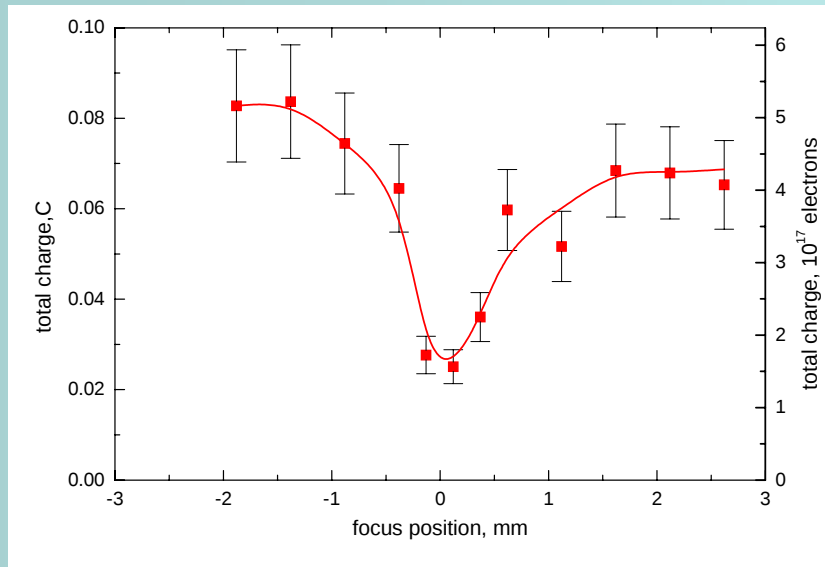
**2. Comparison of ion emission from high-Z plasmas
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**ION COLLECTOR SIGNALS IN THE FUNCTION OF THE ION ARRIVING TIME
AND IN THE FUNCTION OF TARGET DISPLACEMENTS**

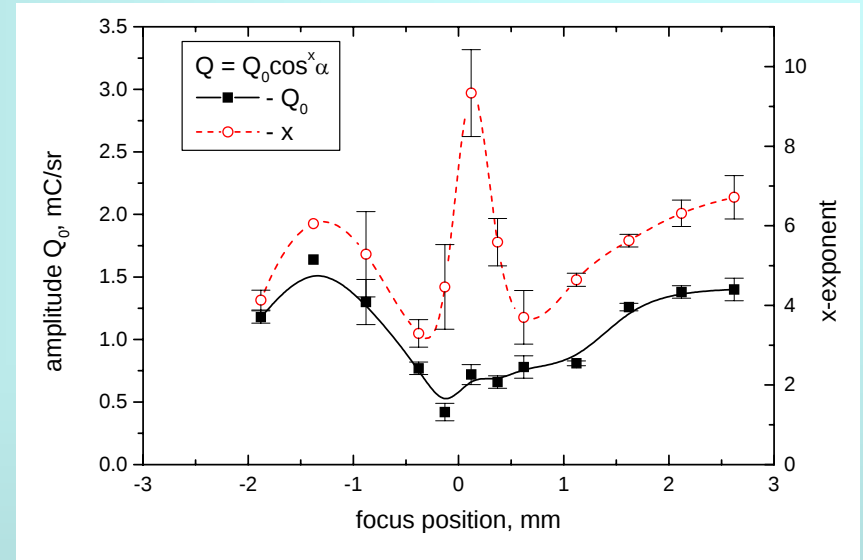


2. Comparison of ion emission from high-Z plasmas generated by a high energy PALS laser at the fundamental and at the 3rd harmonic frequencies

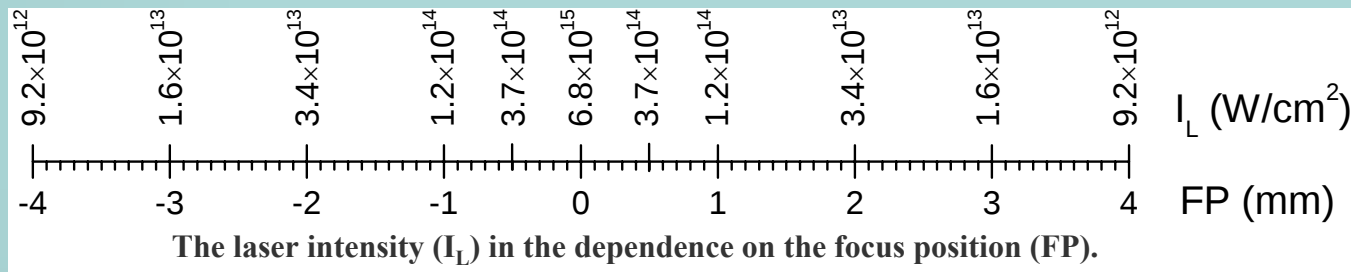
DEPENDENCE OF Ag ION STREAM PARAMETERS ON A FOCUS POSITION AT $1\omega_0$



The total charge carried by ions as a function of focus position.

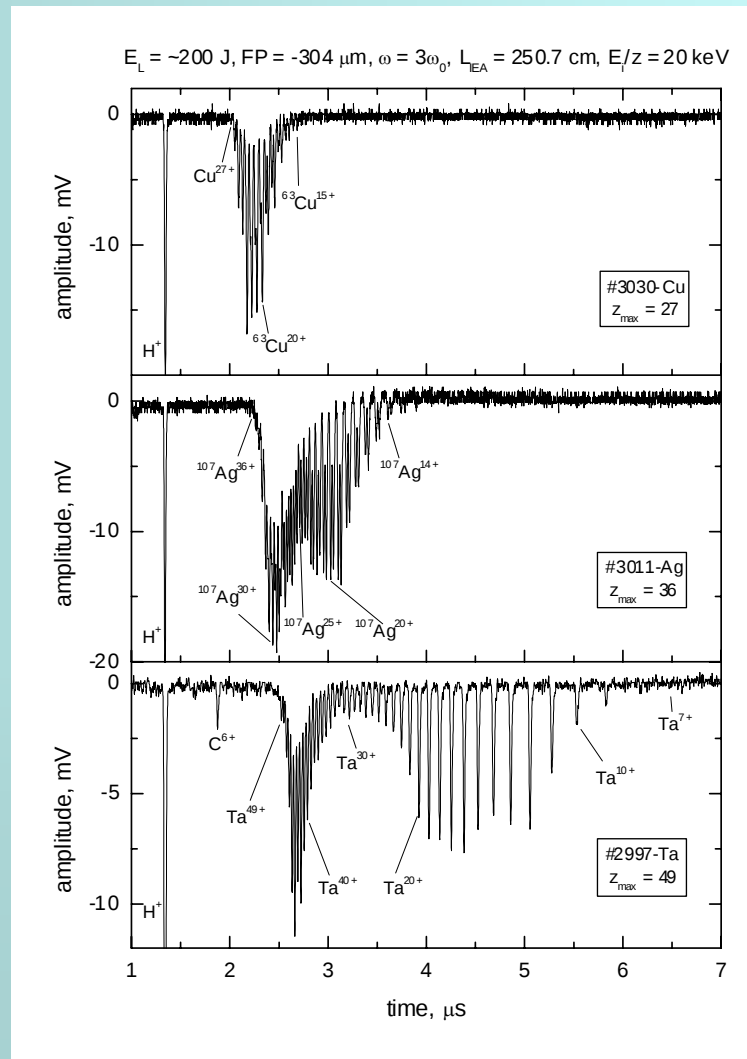


The amplitude of Q_0 and x -exponent of ion angular distributions roughly described by $Q = Q_0 \cos^x(\alpha)$



**2. Comparison of ion emission from high-Z plasmas
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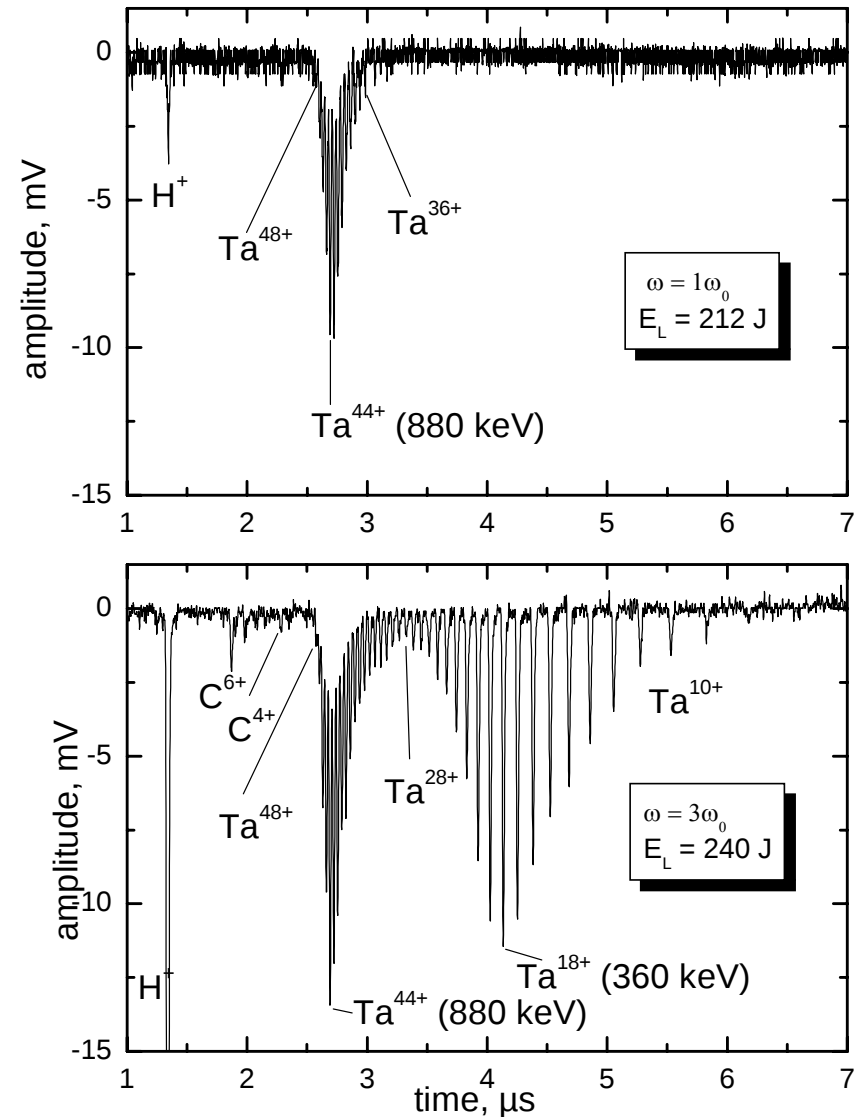
**EXAMPLES OF THE IEA SPECTRA OF Cu, Ag AND Ta LASER-GENERATED
IONS RECORDED AT THE SAME EXPERIMENTAL CONDITIONS**



2. Comparison of ion emission from high-Z plasmas generated by a high energy PALS laser at the fundamental and at the 3rd harmonic frequencies

IEA SPECTRA OF Ta IONS RECORDED AT 1315 nm AND 438 nm

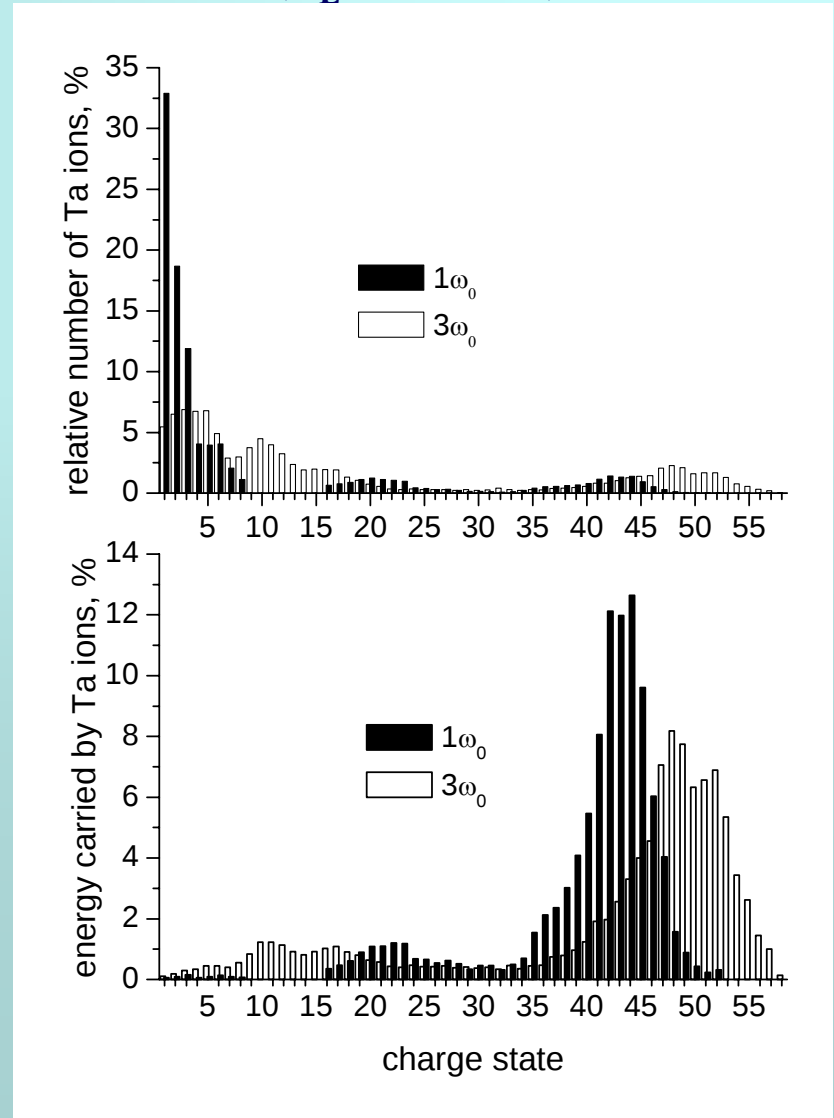
- The group of *fast highly charged Ta ions* is represented by a part of the spectrum recorded from ~ 2.4 to ~ 3.5 μs .
- The shapes of the IEA spectra for both wavelengths are different.
- In particular, the stream of *medium-charged and medium energy ions* was much more intense in the case of visible radiation than at infrared laser radiation.



**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

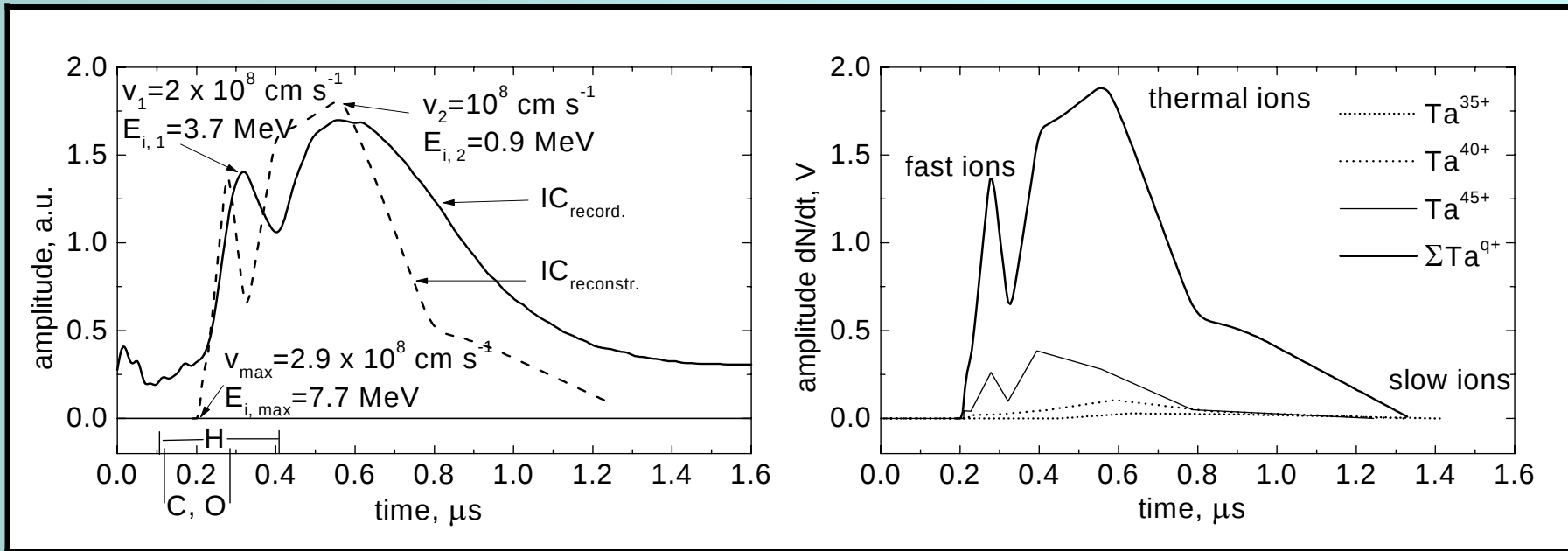
**DISTRIBUTION OF Ta ION ENERGY (TOP) AND
ABUNDANCE (BOTTOM) WITH CHARGE ($E_L \sim 225 \pm 15$ J).**

- The group of *highly charged* ($z > 35$) Ta ions, which carried a significant part of the total energy of all the ions is shown in the diagram.
- In the case of *1315 nm* radiation this group is *more significant* than for 438 nm light.



**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

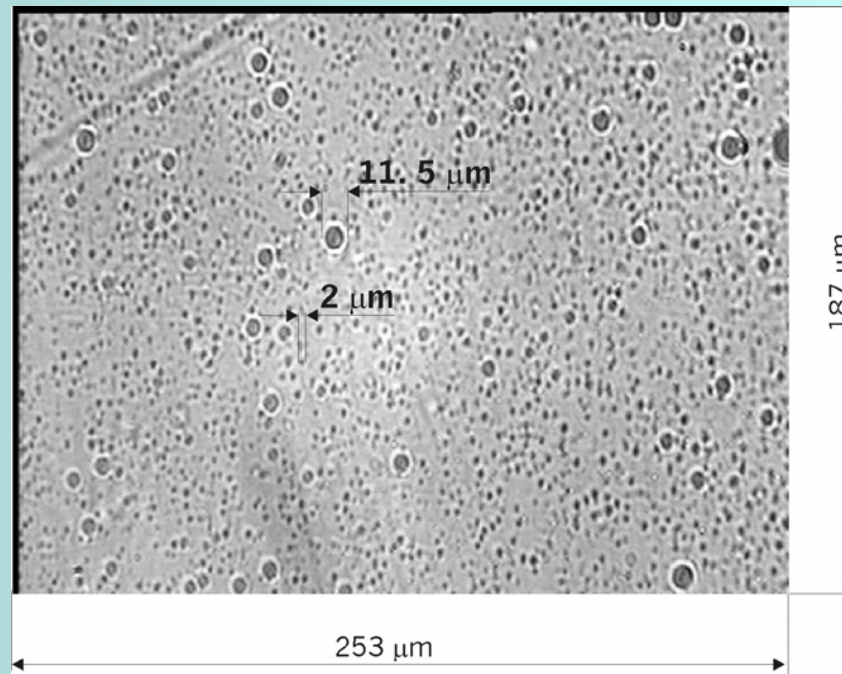
ION COLLECTOR SIGNALS RECORDED AND RECONSTRUCTED ON THE BASIS OF THE *IEA* MEASUREMENTS AT $1\omega_0$



$E_{i,1}, E_{i,2}$, - fast and thermal ion energies, respectively,
 v_1, v_2 - velocities of fast and thermal ions, respectively.

**2. Comparison of ion emission from high-Z plasmas
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and at the 3rd harmonic frequencies**

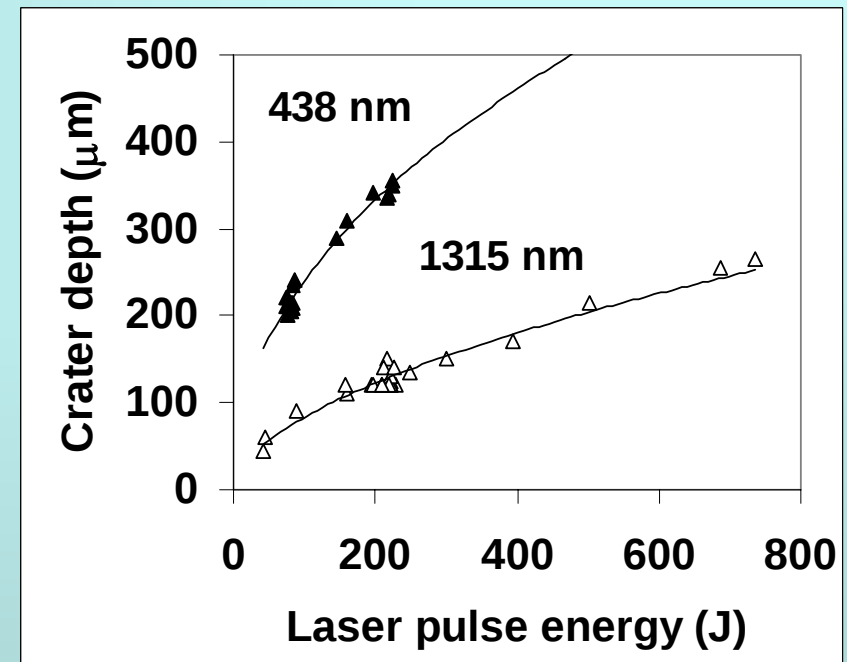
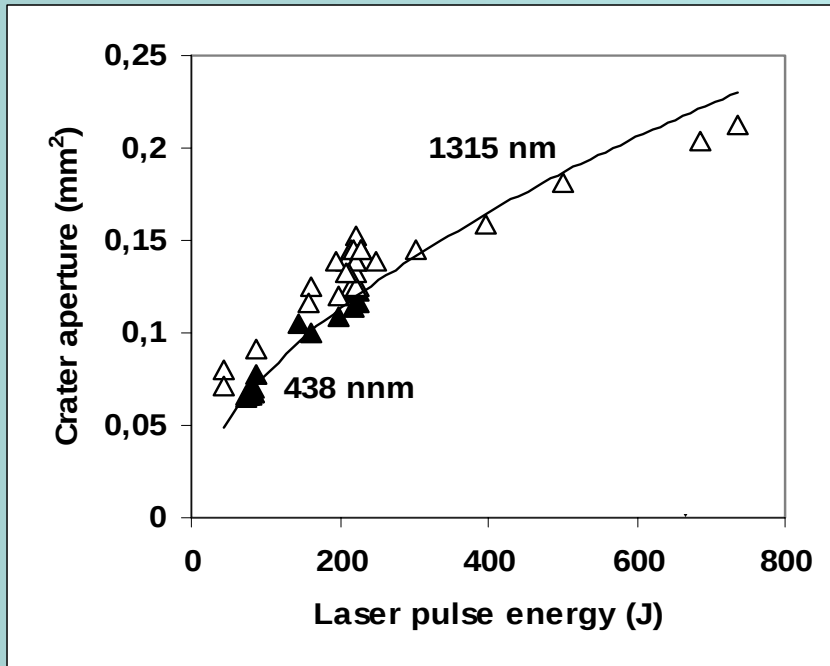
**MEASUREMENTS OF FAST IONS WITH THE USE OF
SOLID STATE TRACK DETECTORS**



- Ion tracks were recorded on the PM-355 detector covered with a ***4 μm Al-foil filter*** (three laser shots at $E_L \approx 80$ J).
- The ***tracks of larger diameter*** were induced by ***energetic (>22 MeV) Ta ions***. The ***small diameter tracks*** were produced by ***protons of energy >0.5 MeV***.
- Track densities of ***>10⁷ tracks/cm²*** for Ta-ions were observed.
- The Ta ion energies corresponded well to the maximum Ta ion energies determined from the ion collectors signals.

2. Comparison of ion emission from high-Z plasmas generated by a high energy PALS laser at the fundamental and at the 3rd harmonic frequencies

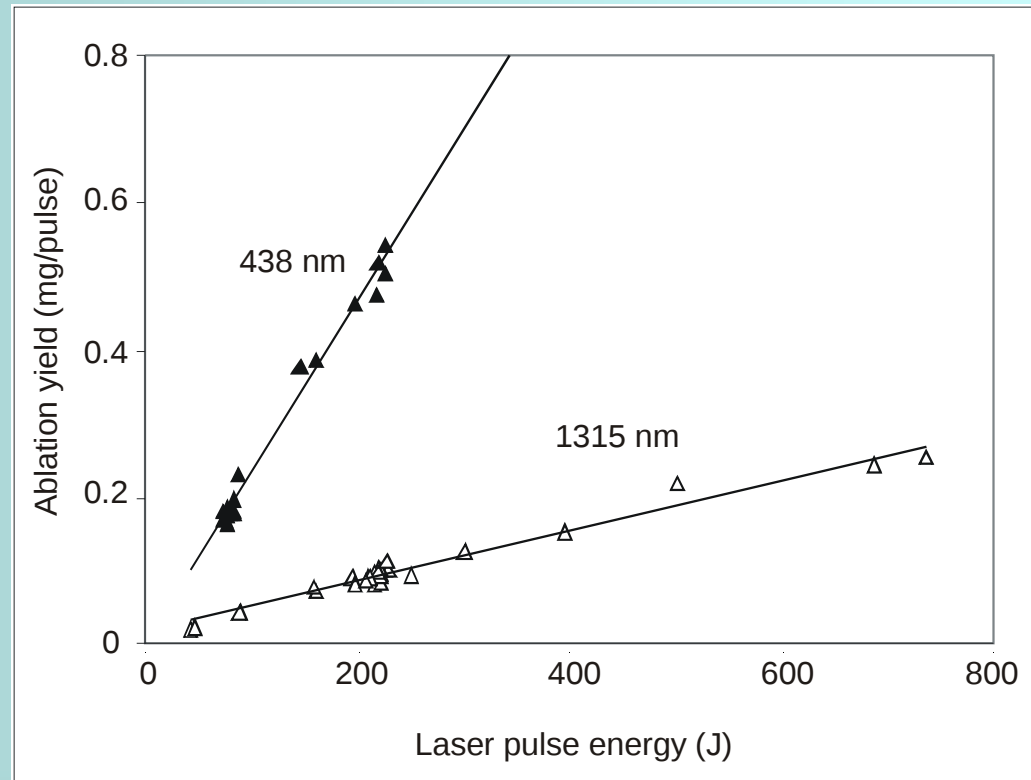
DIMENSIONS OF CRATERS PRODUCED IN THE TARGETS A FUNCTION OF THE LASER PULSE ENERGY



- The craters produced were analyzed by a *scanning electron microscope and by a high sensitivity profiler system*.
- The *crater diameters increase* with the laser pulse energy *similarly* for the both laser wavelengths.
- But the *crater depths increases* with energy *faster for visible laser radiation* in comparison with the depths of the craters produced by the infrared laser.

2. Comparison of ion emission from high-Z plasmas generated by a high energy PALS laser at the fundamental and at the 3rd harmonic frequencies

ABLATION YIELD OF A TARGET MATERIAL AS A RESULT OF LASER-TARGET INTERACTION



- **High ablation yields (0.1-0.6 mg per pulse)** were measured as a function of the laser pulse energy at both the wavelengths.
- At **438 nm** significantly **higher ablation rates** were observed.

***3. Correlation of the x-ray
and ion emissions from high-Z plasmas generated
by a high energy PALS laser system***

INTRODUCTION

Ion and x-ray emission from laser plasmas often needs to be modified *to fit the specific applications*.

The *changing of the focusing condition* of the laser beam is the easiest method of modification of the *characteristics of ion and x-ray beams*.

It is difficult to keep the same level of focusing in the broad range of laser energy because the convergence of the laser beam may change to a great extend.

In our experiment we investigated the *ion and x-ray emission* from targets irradiated by means of the PALS laser system operating at a pulse energy of about *100 J*.

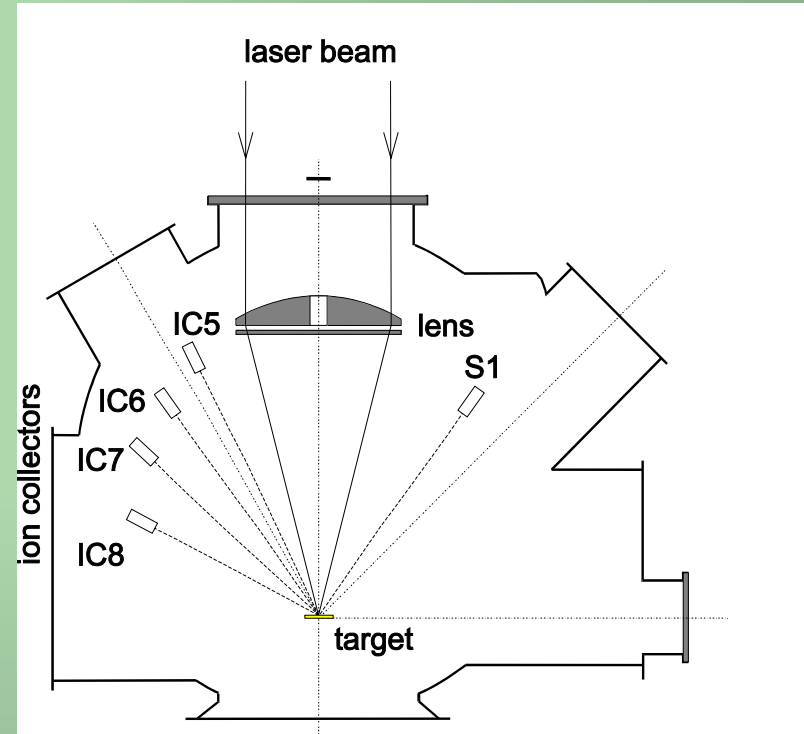
The *lens-target distance* was changed in the broad range up to $\pm 3 \text{ mm}$ to obtain the full picture of the observed phenomena.

We hope the acquired overall picture of the observed phenomena will become useful in *interpretations of our experimental of results*.

3. Correlation of the x-ray and ion emissions from high-Z plasmas generated by a high energy PALS laser system

EXPERIMENTAL SET-UP

- The laser operated at the *fundamental frequency* (wavelength $1.315\ \mu\text{m}$.) and at 0.4-ns pulse energy of $\sim 100\ \text{J}$.
- The *focus position* was change in the range of $\pm 3\ \text{mm}$ which resulted in changing the *laser spot diameter* from ~ 70 to $\sim 1300\ \mu\text{m}$ and the *laser pulse intensity* from 2×10^{13} to $7 \times 10^{15}\ \text{Wcm}^{-2}$.
- The laser beam was focused **perpendicular to the Ag or Ta target surface**.



Ion collectors were placed in the experimental chamber at different distances (from 42 to 60 cm) and angles (from 23° to 62°).

The *X-ray measurements* were performed with the use of **6 photodiodes** covered with different filters and located at different distances from target.

The photodiodes were supplied from *small batteries* which are less sensitive to the *external noise*.

3. Correlation of the x-ray and ion emissions from high-Z plasmas generated by a high energy PALS laser system

CHARACTERISTICS OF THE PHOTODIODES

For the measurement of *soft component* BPYP03 and BPYP03s photodiodes were used, which are made of low-resistance silicon, and are characterised by an *active layer* of about $2\ \mu\text{m}$ (at 20-V bias) and a *dead layer* of about $0.15\ \mu\text{m}$.

For the measurement of the *harder component* (up to 20 keV) three FLM photodiodes were used. They are of *380- μm . active-layer* thickness and of $25\ \text{mm}^2$ active surface.

The *fastest detector* used in this study was BPYP42 photodiode of *40- μm . active layer* (at 100-V bias). The rise time of the detector was only $300\ \text{ps}$ due to the *low surface* ($0.1\ \text{mm}^2$) and resulting from it a low internal capacitance.

photodiode / head type	active layer [μm] (bias)	rise time [ns]	active area [mm^2]	x-ray filter	ranges of sensitivity [keV]	Distance [cm] / remarks
BPYP03	2 (20V)		7.56	7 μm Al	0.9-1.5 (2.4-7.1)	154 / detect. for soft X rays
BPYP03s	2 (20V)	3	0.874	3 μm Al	0.7-1.5 (1.9-5.5)	277 / fast detect. for soft X rays
BPYP42	40 (70V)	0.3	0.1	54 μm Al	5.5 – 15.7	87 very fast detect. for hard X-rays
FLM	380		25	1.2 mm Be + 7 μm Al	5.1-20.0	154 / detect. for hard X-rays
FLM/integ	380		25	14 μm Al	1.3-1.5 (4.2-19.7)	120 / detect. for hard X-rays
FLM/integ	380		25	14 μm Al	1.3-1.5 (4.2-19.7)	164 / detect. for hard X-rays

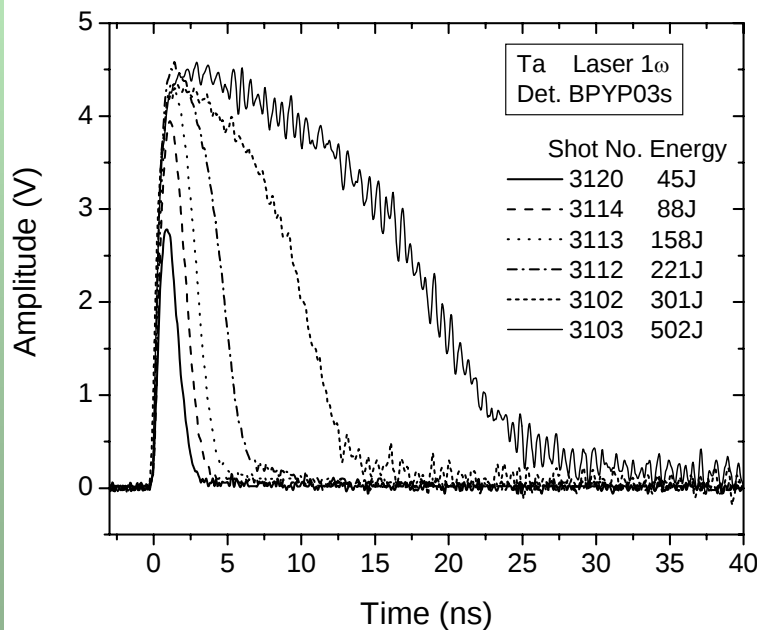
The detectors for the *soft x-ray component* (BPYP02 and BPYP03s) exhibit *two ranges of sensitivity*: at about 1 keV and at about 4 keV, but the contribution from the *second one is low importance* because *intensity of x-ray radiation is dropping fast* with rising x-ray energy.

The output signals from two *FLM/integ* photodiodes *were integrated* on an external capacitor.

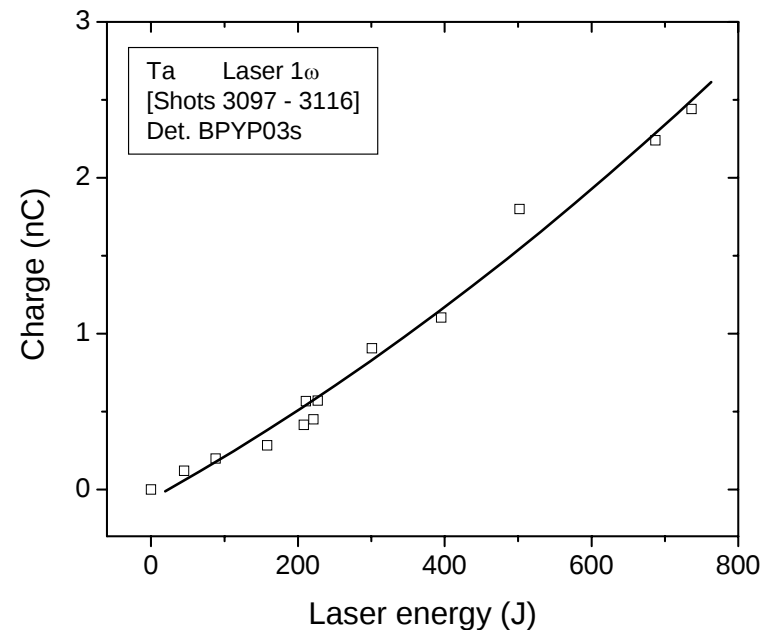
3. Correlation of the x-ray and ion emissions from high-Z plasmas generated by a high energy PALS laser system

OVERLOADING OF THE SOFT X-RAY DETECTORS

- The *FLM photodiodes operate without a visible distortion up to laser pulse energy of 740 J*.
- A distinct *saturation* (broadening) of the recorded signals appears *above 200 J* in the case of *BPYP03s photodiode*.
- Detectors such as BPYP03 or BPYP03s are mostly exposed to *overloading* because the soft radiation interacts in a *very thin active layer*, which results in the generation of *high density of charge carriers* which causes *weakens the electric field and delays the charge collection*.
- In the case of detectors from materials of prolonged lifetime of carriers (e.g. BPYP03s photodiode) *no saturation effects were noticed for signals obtained by the integration of the area under a response peak*.
- The *useful dynamic range of photodiode* may be extended by changing the method of collecting the output signals, *from the time resolving to the time integrating one*.



An example of BPYP03s photodiode overloading.



Response of BPYP03s photodiode to x-ray pulse, expressed as the charge collected from the detector, versus laser energy.

3. Correlation of the x-ray and ion emissions from high-Z plasmas generated by a high energy PALS laser system

SOFT AND HARD X-RAY EMISSIONS FROM Ag (A) AND Ta (B) TARGETS AS A FUNCTION OF LASER FOCUS POSITION AND LASER INTENSITY

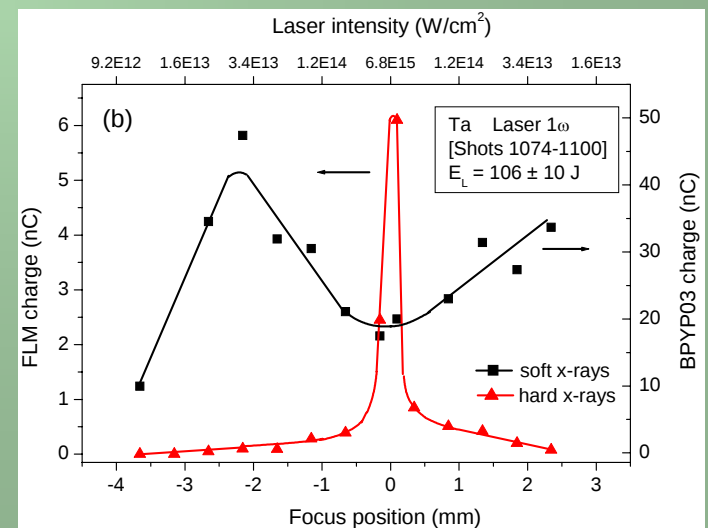
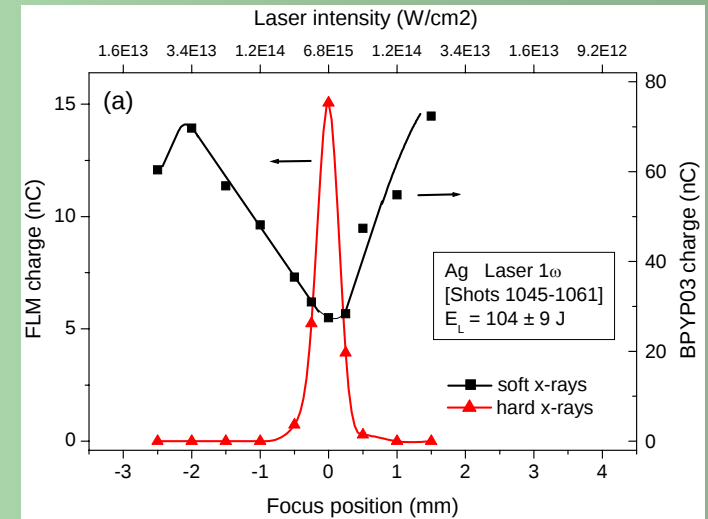
In this case the X-rays were measured by the *BPYP03* and *FLM photodiodes* filtered by $7\ \mu\text{m Al}$ and $1.2\ \text{mm Be}$, respectively.

Detectors were placed at a distance of $154\ \text{cm}$ from the target.

Laser energy was $105 \pm 10\ \text{J}$ (at the wavelength of $1.315\ \mu\text{m}$).

The x-axis scales have been *normalised* (by shifting) to establish the hard x-ray maximum at “0” focus position.

Negative values on x-axis imply that the laser focus is *in front* of the target surface.



COMPARISON OF SIGNALS FROM EMISSIVE (S1) AND NON-EMISSIVE (IC6) ION COLLECTORS (after normalisation to the same distance)

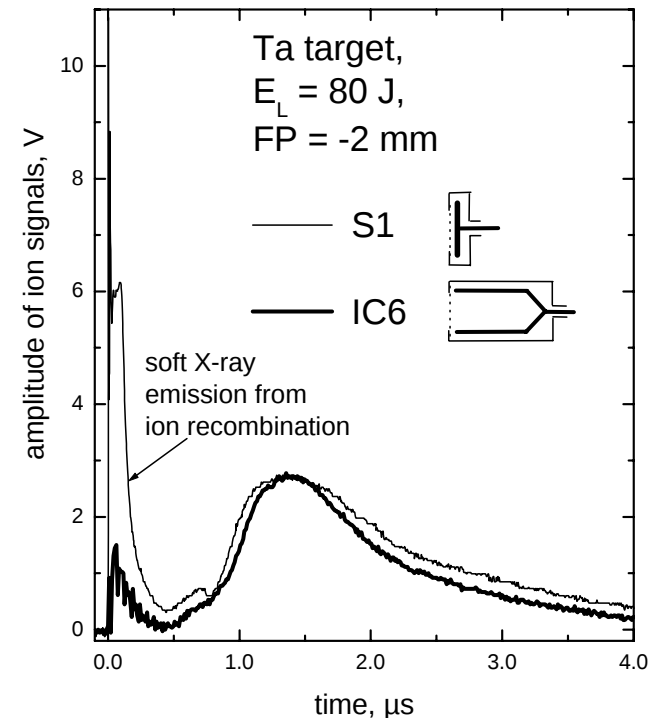
Two types of collectors were used: non-emissive ones - IC5-IC8 and a standard one S1

- The responses to the *thermal ions at the time about 1.2 μs are very similar*, but there is a big difference in response to the *photopeak and the fast component* which appears immediately after the photopeak and spreads *up to 0.5 μs* .

- As the non-emissive collector is practically non-sensitive to the *fast component*, we conclude that it must come from *soft x-ray radiation* that is produced in expanding plasma by the process of *recombination*.

- The trace of a group of *light contaminant ions and fast heavy ions* is seen at about *0.7 μs* .

- The *much slower component* of low amplitude of the IC signal which appears later than *4 μs* was omitted for simplification.



CHARACTERISTICS OF X-RAY AND THERMAL ION EMISSION IN DEPENDENCE ON A FOCUS POSITION

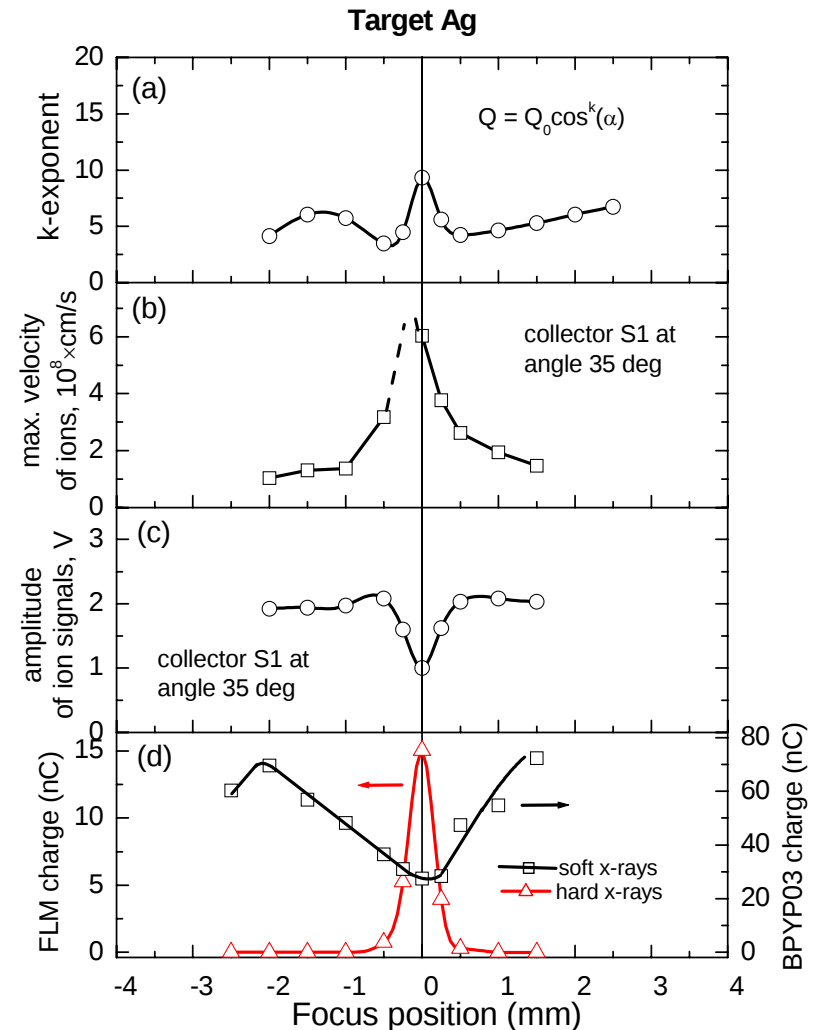
The *soft and hard X-ray emission* measured by **BPYP03** and **FLM photodiodes**, filtered by $7\ \mu\text{m}$ Al and $1.2\ \text{mm}$ Be, respectively, *differs to a great extend*.

The emission in the *soft channel* is related to the *volume of the plasma*, which becomes the smallest just the case of sharp focusing.

The peaking of the *hard X-ray emission* indicates the most intense production and then interaction of *fast electrons* with surrounding plasma and target material.

The hard x-ray emission is a of *a threshold nature* and for Ag plasma starts at intensity about $6.3 \times 10^{14}\text{W}/\text{cm}^2$.

x-scale has been normalised to establish the *hard X-ray maximum at '0' focus position*.



***4. FAST ION GENERATION
IN THE PLASMA PRODUCED BY
A 1-ps HIGH INTENSITY LASER PULSE***

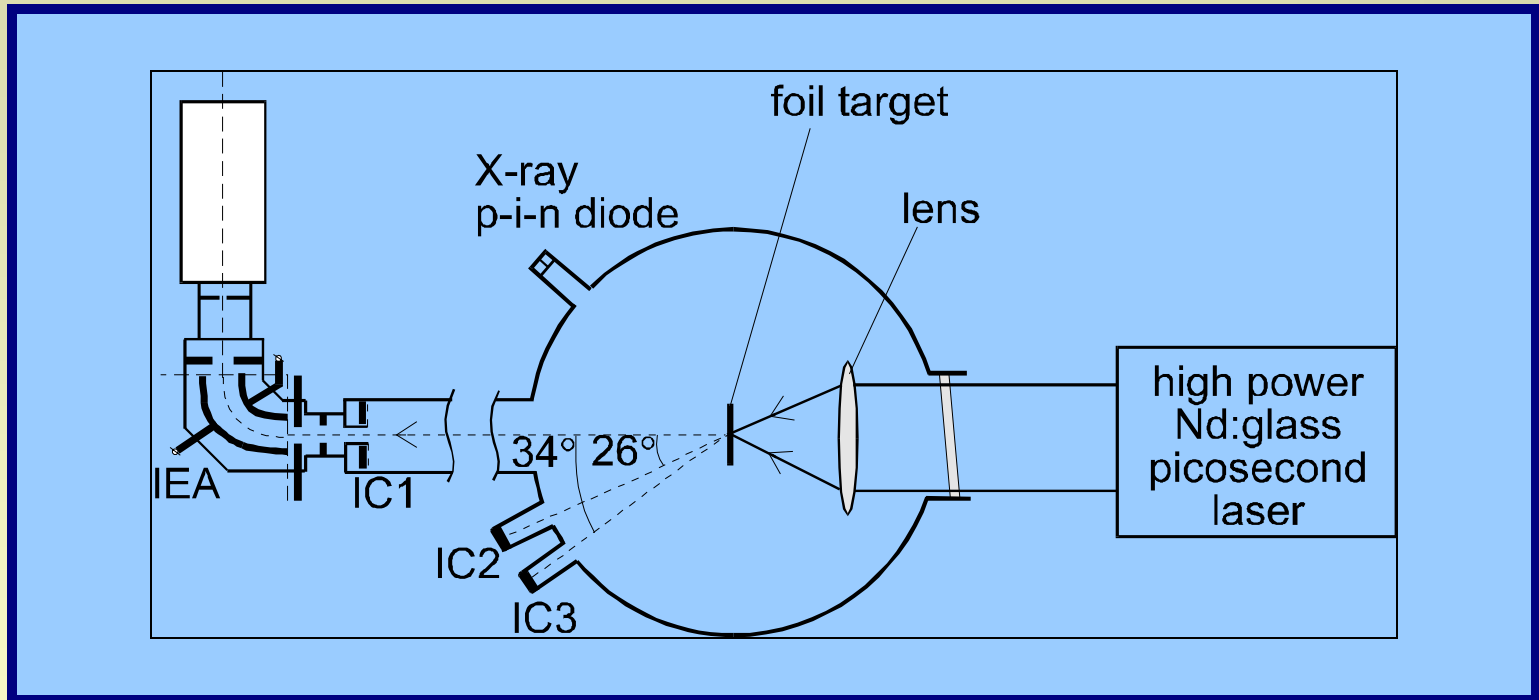
***4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse***

**EXPERIMENTAL SET-UP FOR STUDIES OF THE ION STREAM
GENERATED WITH THE USE OF THE 1-ps TERAWATT LASER SYSTEM**



**4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse**

SCHEME OF THE EXPERIMENTAL ARRANGEMENT



IEA – electrostatic ion-energy analyzer with windowless electron multiplier;
IC1, IC2, and IC3 – ion collectors.

**4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse**

**THE 1-ps TERAWATT LASER SYSTEM FOR STUDIES
OF THE LASER-MATTER INTERACTION
AT INTENSITIES UP TO 10^{17} W/cm²**



4. Fast ion generation in the plasma produced by a 1-ps high intensity laser pulse

Forces accelerating ions in plasma

gas dynamic (termokinetic) forces:

$$p = nkT$$

electrostatic (created due to a separation of charges in plasma):

$$\underline{F} = q \underline{E}$$

ponderomotive (created due to inhomogeneity of the laser field and/or plasma): $\underline{F}_p \propto \underline{\nabla} E^2$

Ranges of laser intensity in short-pulse experiments

Relativistic intensity:

$$I_{\text{rel}} \approx 4.1 \times 10^{18} / \lambda^2 \text{ [W/cm}^2, \mu\text{m]}$$

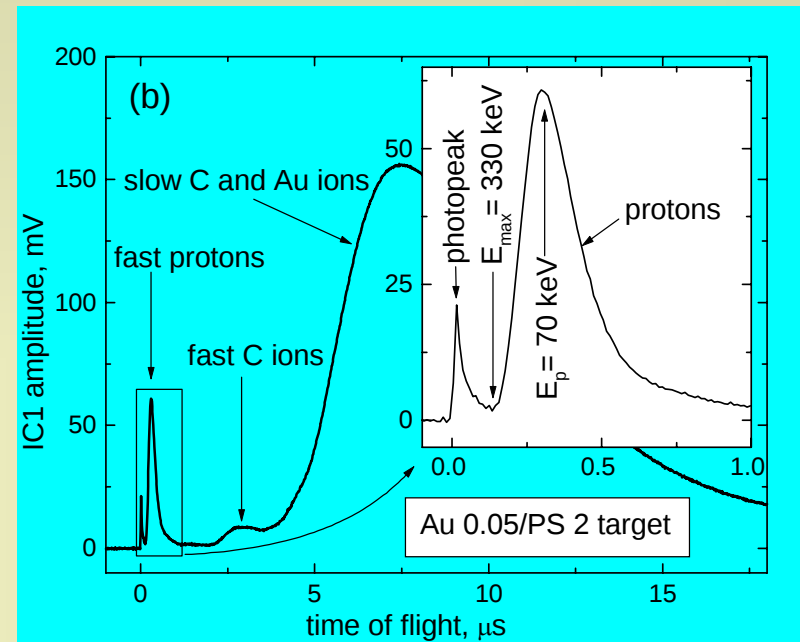
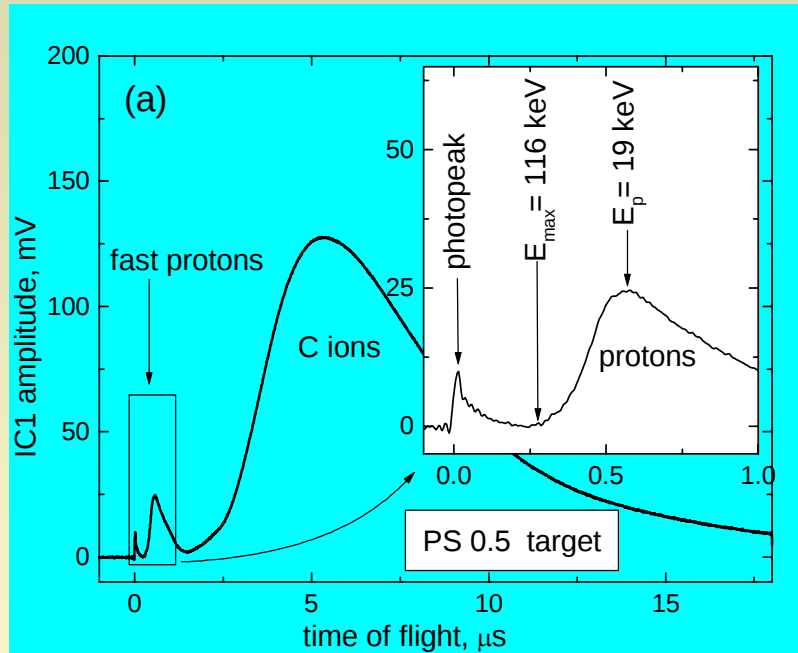
At $I = I_{\text{rel}}$, the oscillation energy of the electron is equal to its rest energy mc^2

- subrelativistic range, $I \ll I_{\text{rel}}$ $I < 10^{18} \text{ W/cm}^2$ at $\lambda \approx 1 \mu\text{m}$
- relativistic range, $I \sim I_{\text{rel}}$ $10^{18} \text{ W/cm}^2 \leq I \leq 10^{20} \text{ W/cm}^2$ at $\lambda \approx 1 \mu\text{m}$
(LLNL, RAL, LULI, LLE)
- ultrarelativistic range, $I \gg I_{\text{rel}}$ $I > 10^{20} \text{ W/cm}^2$ at $\lambda \approx 1 \mu\text{m}$
(LLNL)

IPPLM experiments were performed at *subrelativistic intensities*.

4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse

IC1 COLLECTOR SIGNALS FROM THE Au0.05/PS2 TARGET (a) and THE PS0.5 TARGET (b).
The magnified portions of the signals show the proton peak.

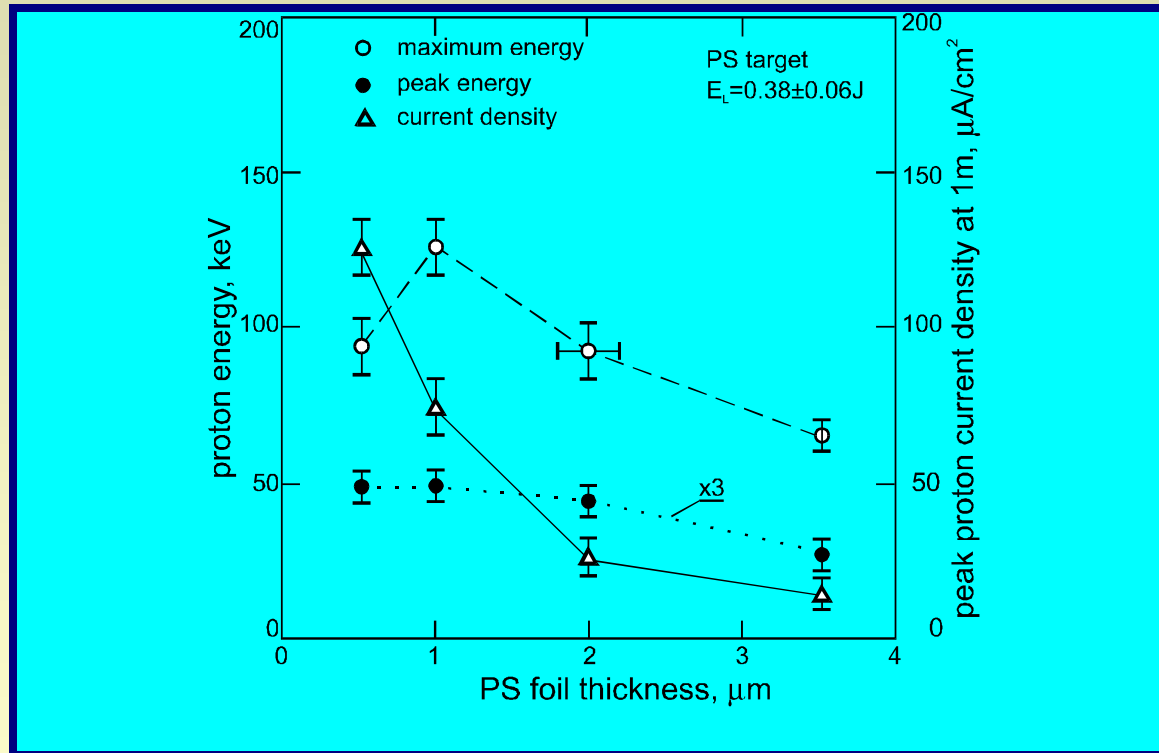


IC signal contains **fast protons**, **C ions** ($\text{C}^{+1} - \text{C}^{+4}$) and **Au⁺¹ ions**.

Both the maximum and mean proton energies as well as the peak proton current density can be determined from IC signal.

**4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse**

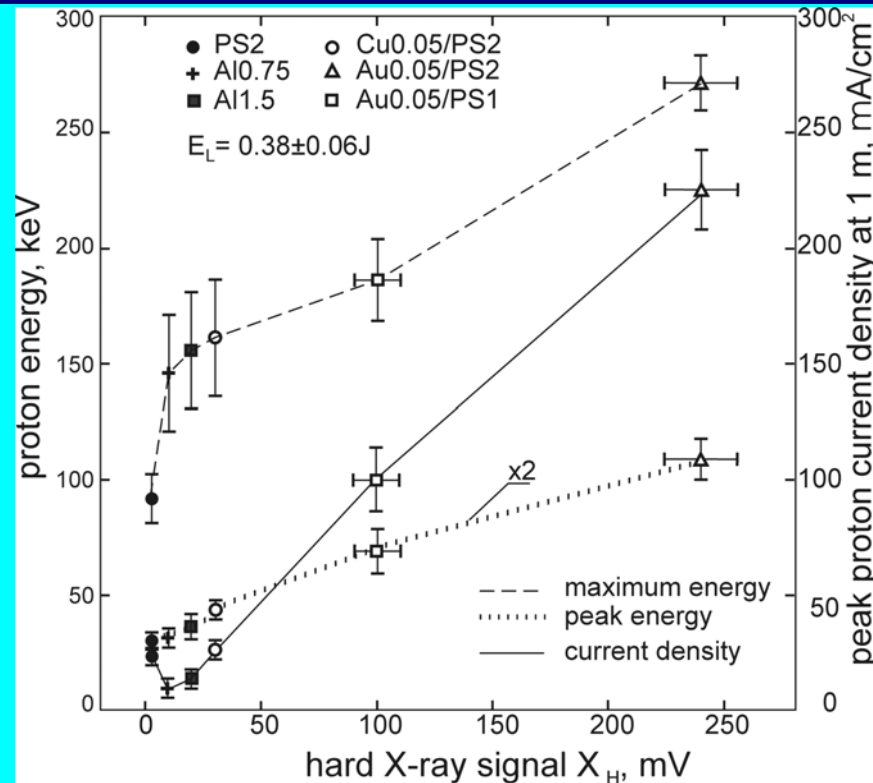
**PARAMETERS OF PROTON BEAMS FROM PS TARGETS
AS A FUNCTION OF THE TARGETS THICKNESS**



**Parameters of proton beams significantly
depend on a total target thickness.**

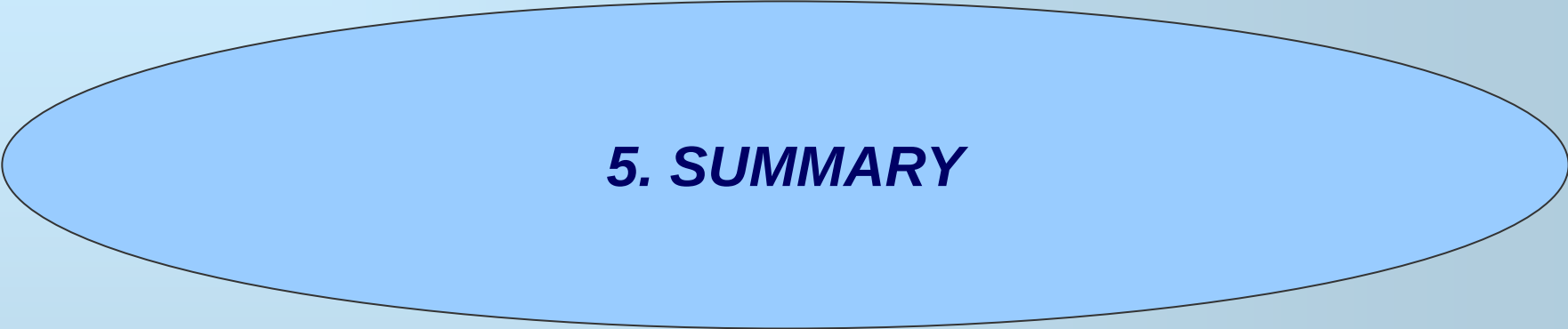
4. Fast ion generation in the plasma produced by
a 1-ps high intensity laser pulse

PARAMETERS OF PROTON BEAMS FROM VARIOUS TARGETS IN CORRELATION WITH X-RAY SIGNAL AT FIXED LASER ENERGY



Parameters of *proton beams* are strongly correlated with the yield of *hard X-rays* produced by hot electrons.

The *highest proton energies* and the *highest proton current densities* have been observed for *double – layer targets* with high – Z layer (Au/PS targets).



5. SUMMARY

**2. Comparison of ion emission from high-Z plasmas
generated by a high energy PALS laser at the fundamental
and at the 3rd harmonic frequencies**

SUMMARY

Using the high-intensity long-wavelength as well as short-wavelength PALS laser pulses (1315 nm and 438 nm, respectively), the production of highly charged, high-energy ions have been demonstrated, *using IC, IEA, and solid-state track detector measurements.*

For Ta ions $z_{max} = 57$ and $E_i > 20$ MeV.

The ion collector signals recorded at higher laser pulse energies clearly show the existence of *three separate ion groups*: fast, thermal and slow.

At high laser pulse energies, $E_L > 200$ J, *fast ion current density* attains $j_{max.} \sim 20$ mA/cm² at the distance of 1 m from the target.

An efficient production of highly charged high-energy ions, by an intense short-wavelength laser pulse with suggests that the mechanisms of the fast ion generation with the use of such laser pulses should be clarified taking into account that the *classical process of fast ion acceleration by hot electrons* escaping from plasma *decreases with the decreasing wavelength.*

Thus, in the case of short-wavelength laser-plasma interactions other phenomena only weakly dependent on the laser wavelength e.g. *ponderomotive forces and self-focusing* of laser radiation may contribute to the *acceleration of ions* in the plasma.

SUMMARY

It was shown that the silicon photodiodes can be applied for reliable measurements of *high-intensity X-ray* emission in the range of *1 - 20 keV* provided from the plasmas produced with the use of the PALS laser system at different experimental conditions.

The detectors for *hard radiation are not overloaded* up to the charge surface density of 84 nC/cm².

The detectors for *soft x-ray radiation* (< 1.5 keV), of a thin active layer, *are mostly exposed to overloading*, which manifests itself in broadening the output pulses.

However, *if the signals undergo integrating*, the detectors' response seems to be *linear* up to type charge surface density of 900 nC/cm². The detectors are then useful up to 740 J of laser energy, as well.

The parameters of both *X-ray and ion emissions* change clearly depending on the lens-target separation and these changes *are well correlated* with each other.

The *most radical changes* in the emission are observed when the target is shifted into a *close vicinity of the focal plane*, which causes the exceeding of *a threshold level of about $6 \times 10^{14} \text{ Wcm}^{-2}$* of the laser intensity (that corresponds to the beam spot of 230 μm.).

The changes are manifested by an *abrupt rise of hard x-ray emission, lowering the amount of ions and narrowing the angle distribution*.

4. Fast ion generation in the plasma produced by a 1-ps high intensity laser pulse

SUMMARY

- We have shown that using *double-layer foil targets* containing high-Z front layer and low-Z hydrogen-rich back layer, instead of commonly used single-layer targets, a considerable *increase in energies and current of protons* produced by an ultrashort-pulse laser is possible.
- Above 10^9 protons of energy $> 100\text{keV}$ have been recorded within a cone angle about 3° near the target normal at intensities 10^{17} W/cm^2 .
- Both the *maximum and the mean proton energies as well as the proton current* are *correlated with the hard x-ray* yield and they increase with the growth of Z-number of high-Z layer.
- For *maximizing the proton energies and/or proton current* both total target thickness and high-Z layer thickness must be *optimally selected*.